

<b>Notice of References Cited</b>	Application/Control No. 10/520,666		Applicant(s)/Patent Under Reexamination KOMURO ET AL.	
	Examiner Peter Y. Choi		Art Unit 1794	Page 1 of 1

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*	B	US-3,906,130	09-1975	Tsurumi et al.	428/131
	C	US-			
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	K	US-			
	L	US-			
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	U				
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	X				

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